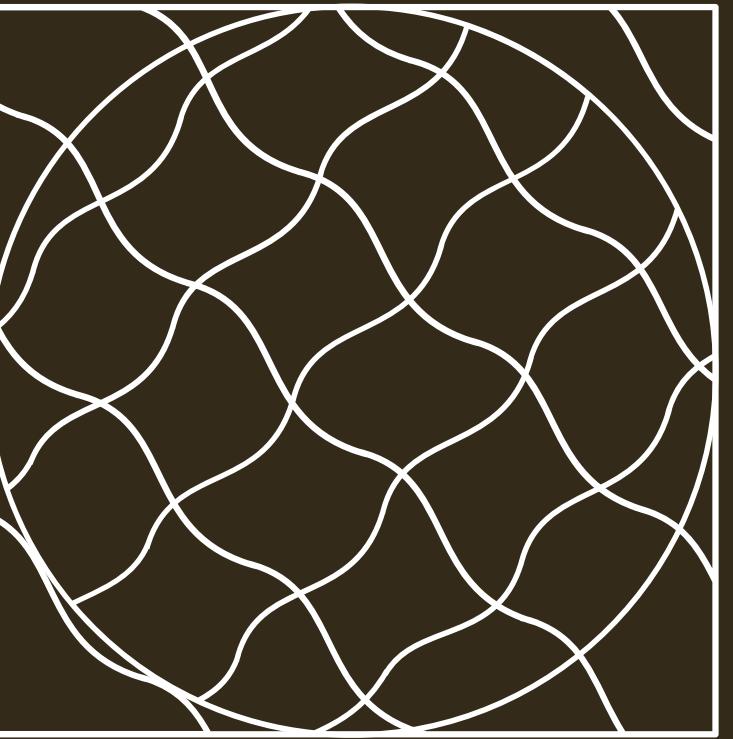
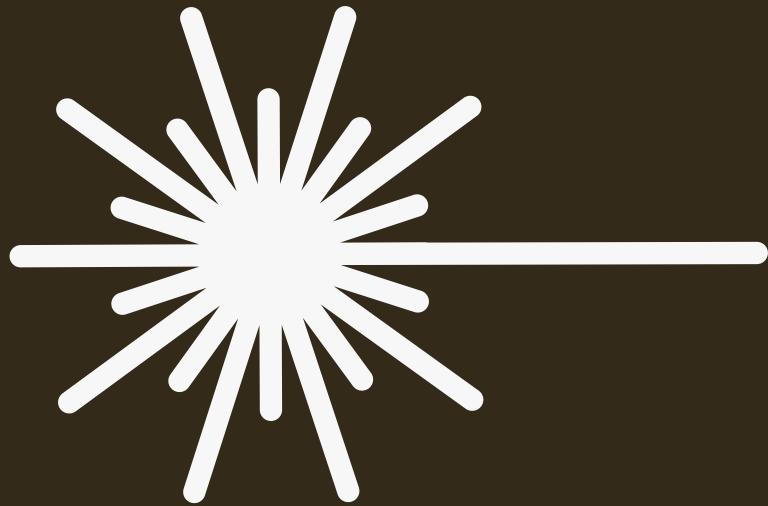
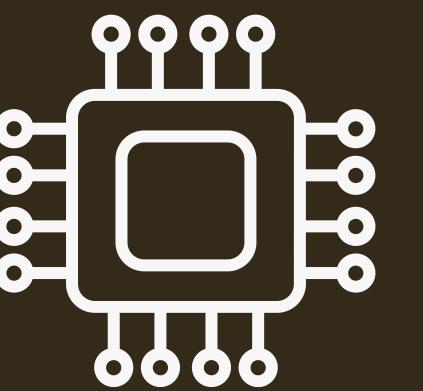


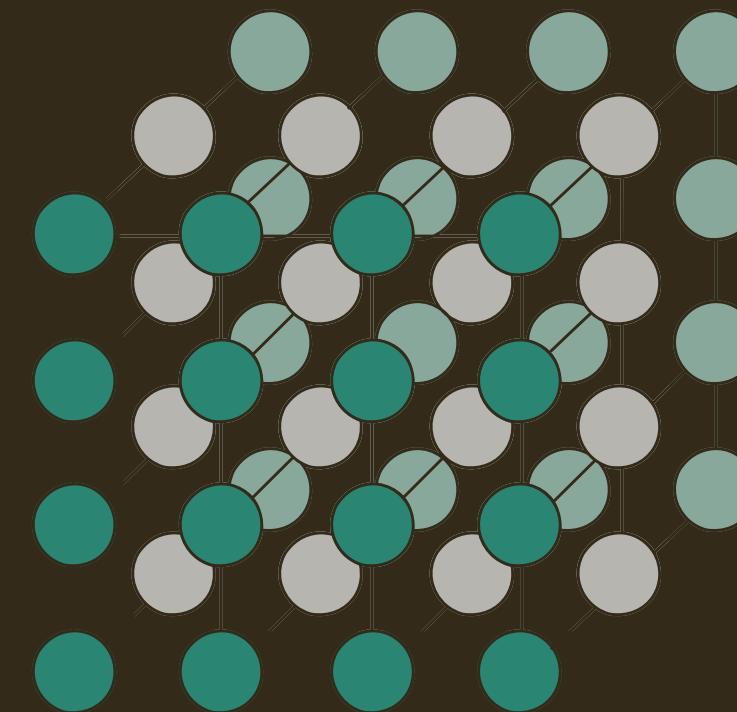
# Reconfigurable Second Harmonic Generation (SHG) in $\text{Si}_3\text{N}_4$

Photonics Integrated Circuits

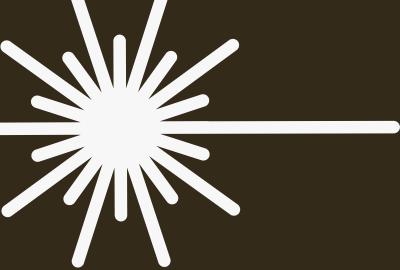
B. E. Castiblanco



# OUTLINE



- 1. Motivation: Why induce  $\chi^2$  in  $\text{Si}_3\text{N}_4$**
- 2. Design**
- 3. Mode simulations**
- 4. Temperature tuning and double-resonance hotspots**
- 5. Effect of All-Optical-Poling (AOP): hotspot expansion and  $\chi^2$  growth**
- 6. SHG performance**
- 7. Outcomes, limitations, and conclusions**



# MOTIVATION: WHY INDUCE $\chi^2$ IN $\text{Si}_3\text{N}_4$

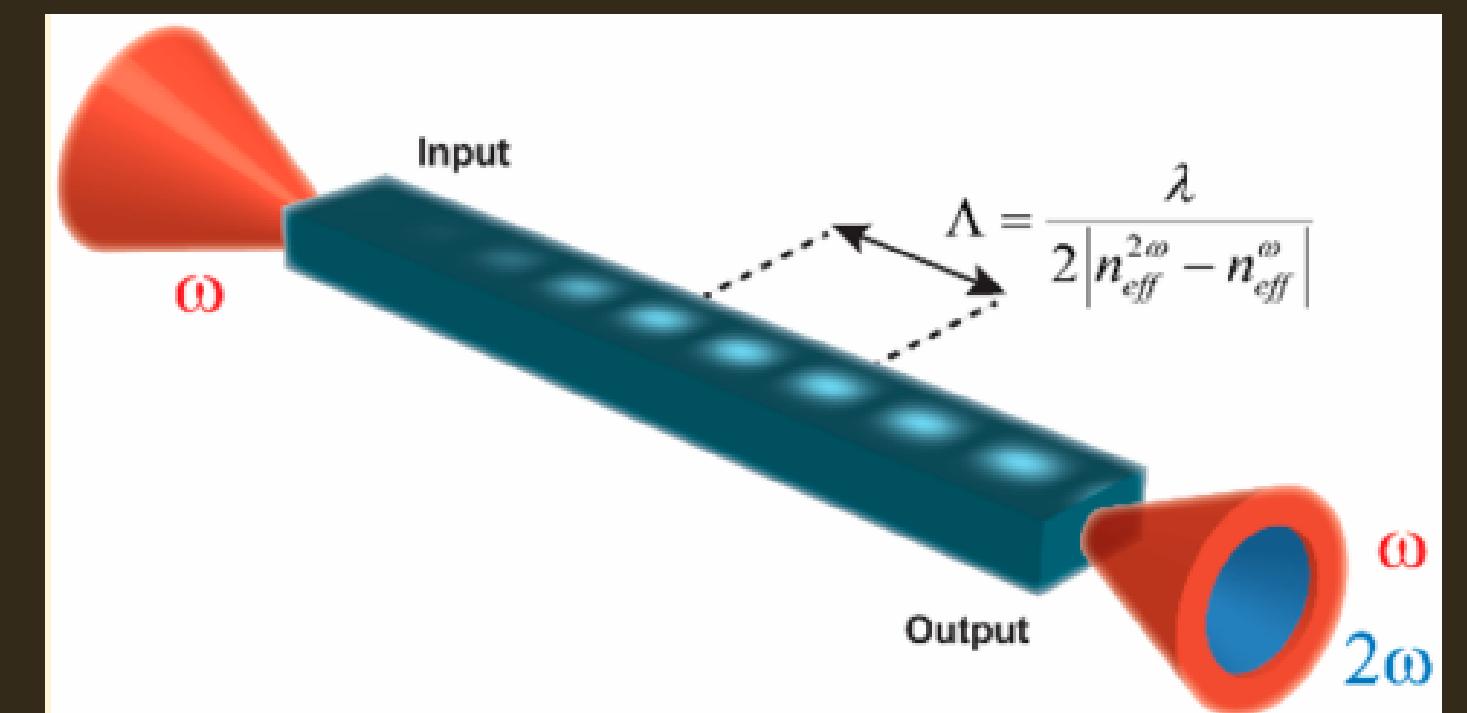
- Silicon nitride is CMOS-compatible
- But SiN is centrosymmetric  $\rightarrow$  no  $\chi(2)$
- All-optical poling (AOP) can induce  $\chi(2)$  inside SiN using only light [1,2]

- Why  $\chi(2)$  instead of relying on  $\chi(3)$ ?

$\rightarrow$  SHG is much more efficient

$\rightarrow$  Generates  $2\omega$  (visible): applications to metrology and sensing applications

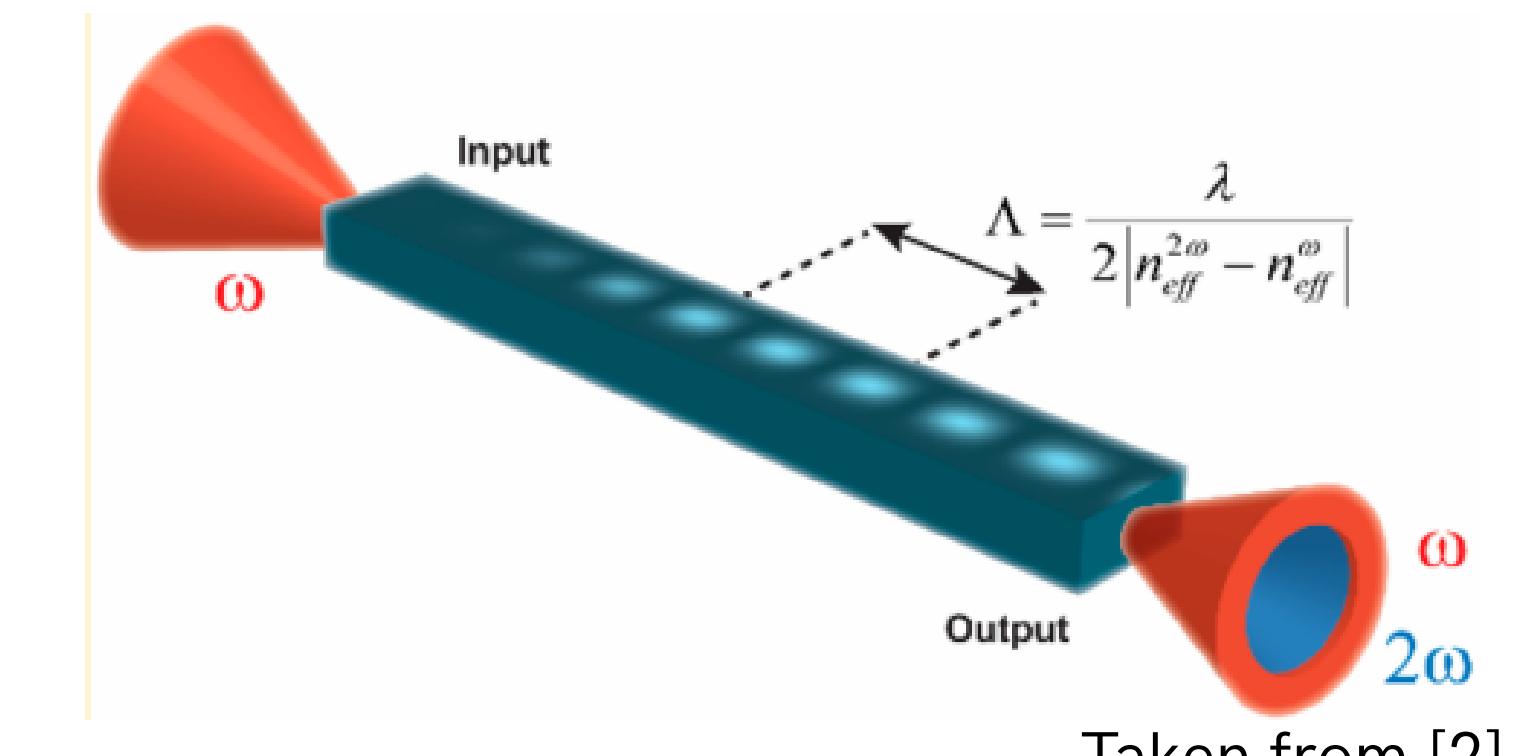
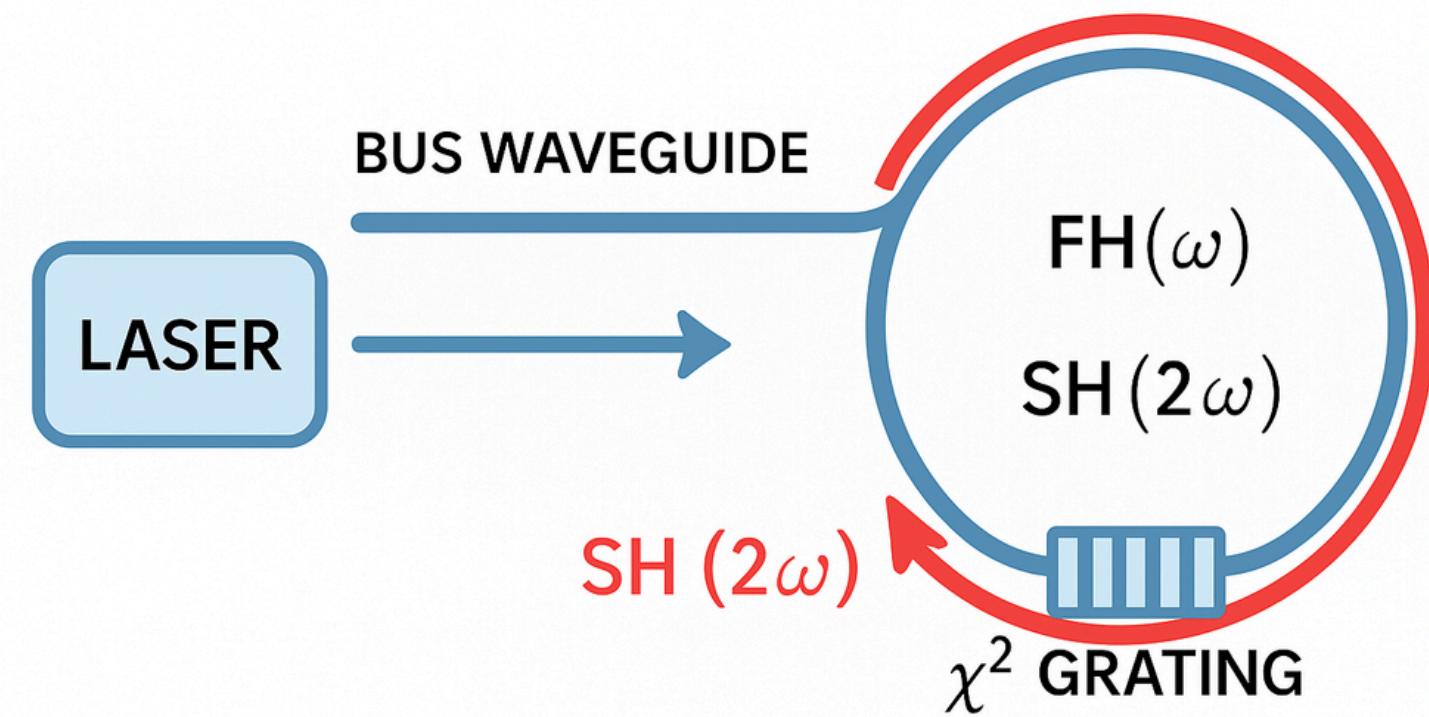
$\rightarrow$  THG requires more optical power



# DESIGN

- $\text{Si}_3\text{N}_4$  microring ( $R = 900 \mu\text{m}$ ) supports FH ( $\omega$ ) and SH ( $2\omega$ ) modes [3]
- Pump laser self-injection locks (SIL) to the FH resonance
- FH and SH circulating together → AOP writes  $\chi(2)$  grating
- $\chi(2)$  grating provides Quasi-Phase Matching (QPM) → enhances SHG

## Schematics



Taken from [2]

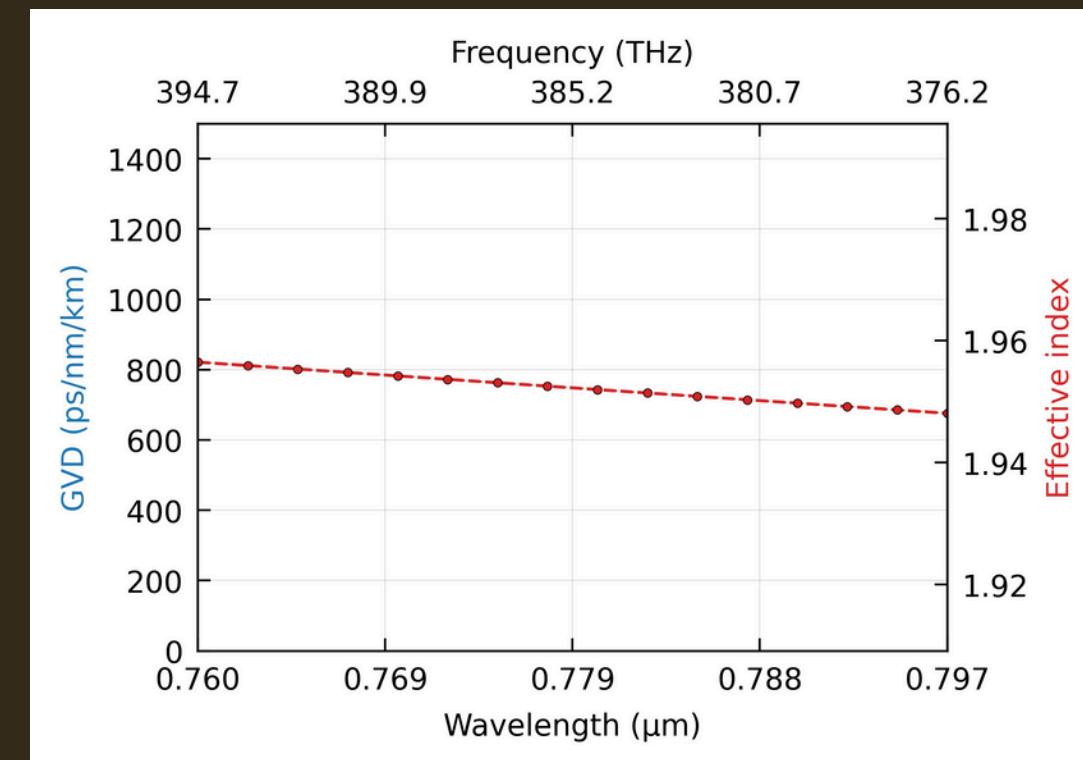
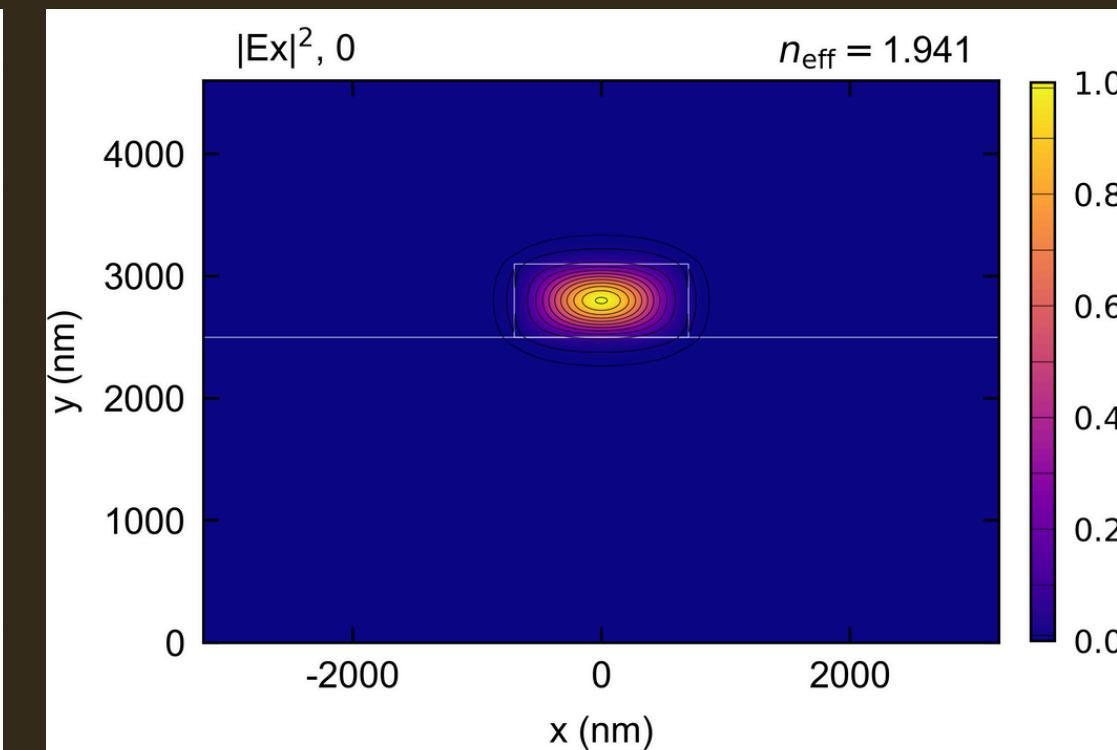
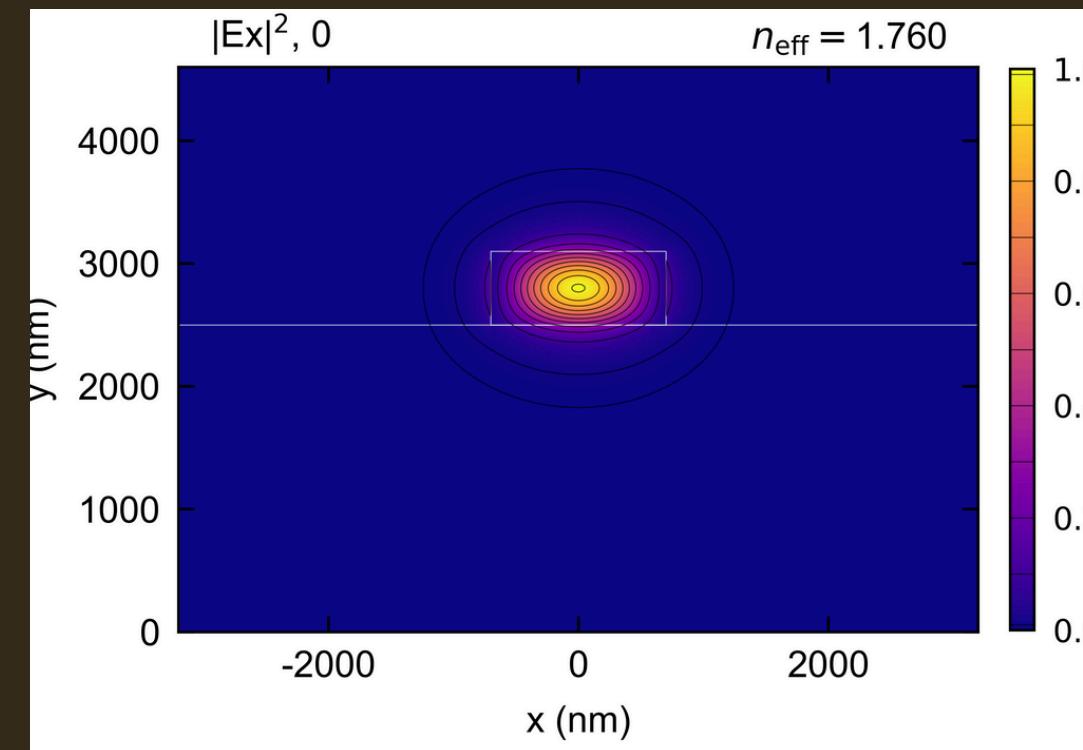
[3] Clementi et al. (2023). Chip-scale SHG via self-injection-locked all-optical poling. *Light: Sci. Appl.*

[2] Nitiss et al. 2019, ACS Photonics

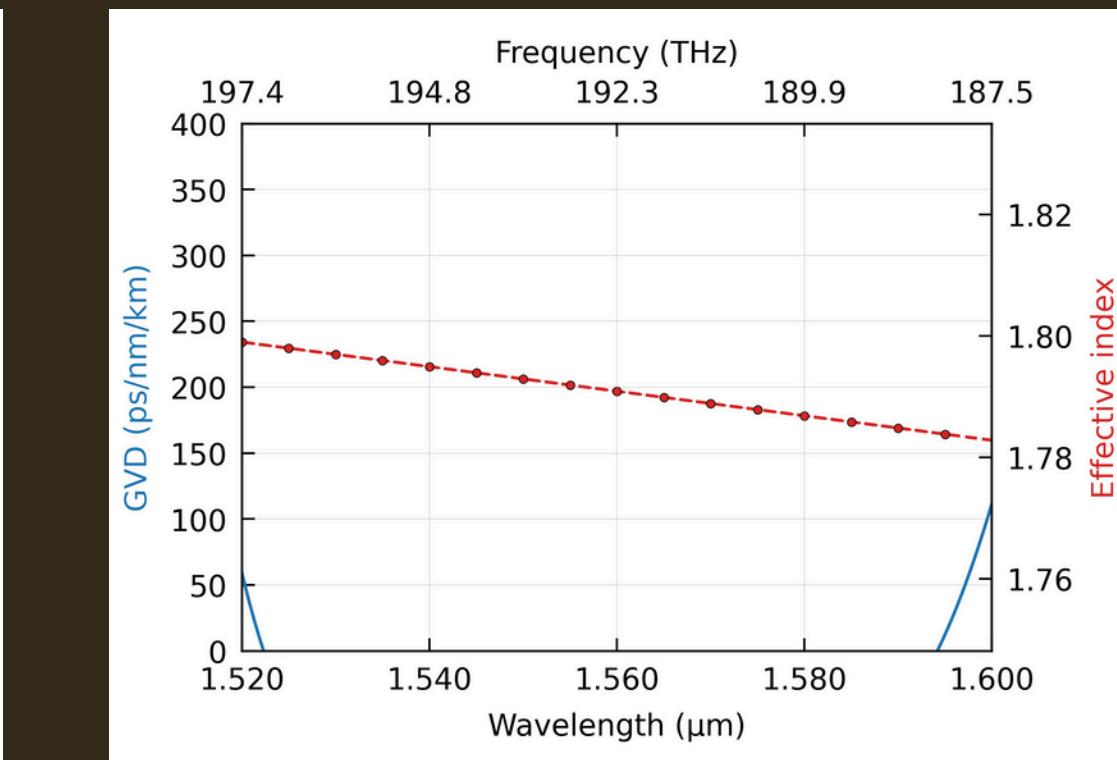
# MODE SIMULATIONS

- Fully buried (silica)  $\text{Si}_3\text{N}_4$
- Sweep in wavelength (C-L bands):
  - FH: 1520-1600 nm
  - SH: 760-800 nm
 (approx linear dispersion/no  $\chi(2)$ )

- Extract  $n_{\text{eff}}(\lambda)$
- Sweep in core width (0.8-1.6  $\mu\text{m}$ )
- Straight waveguide approach:  
 $R = 900 \mu\text{m} \gg \text{core width} \sim 1 \mu\text{m}$



FH mode

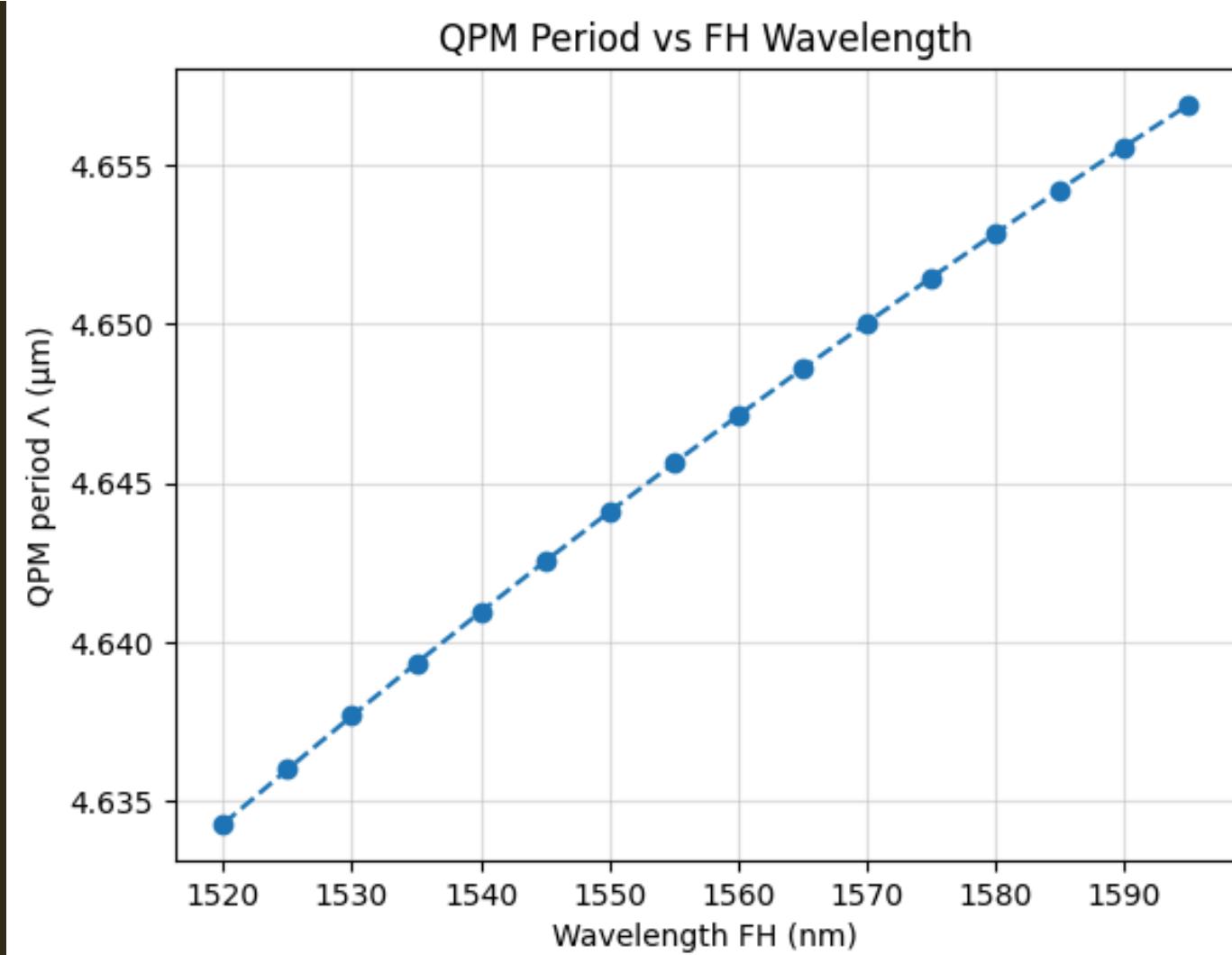
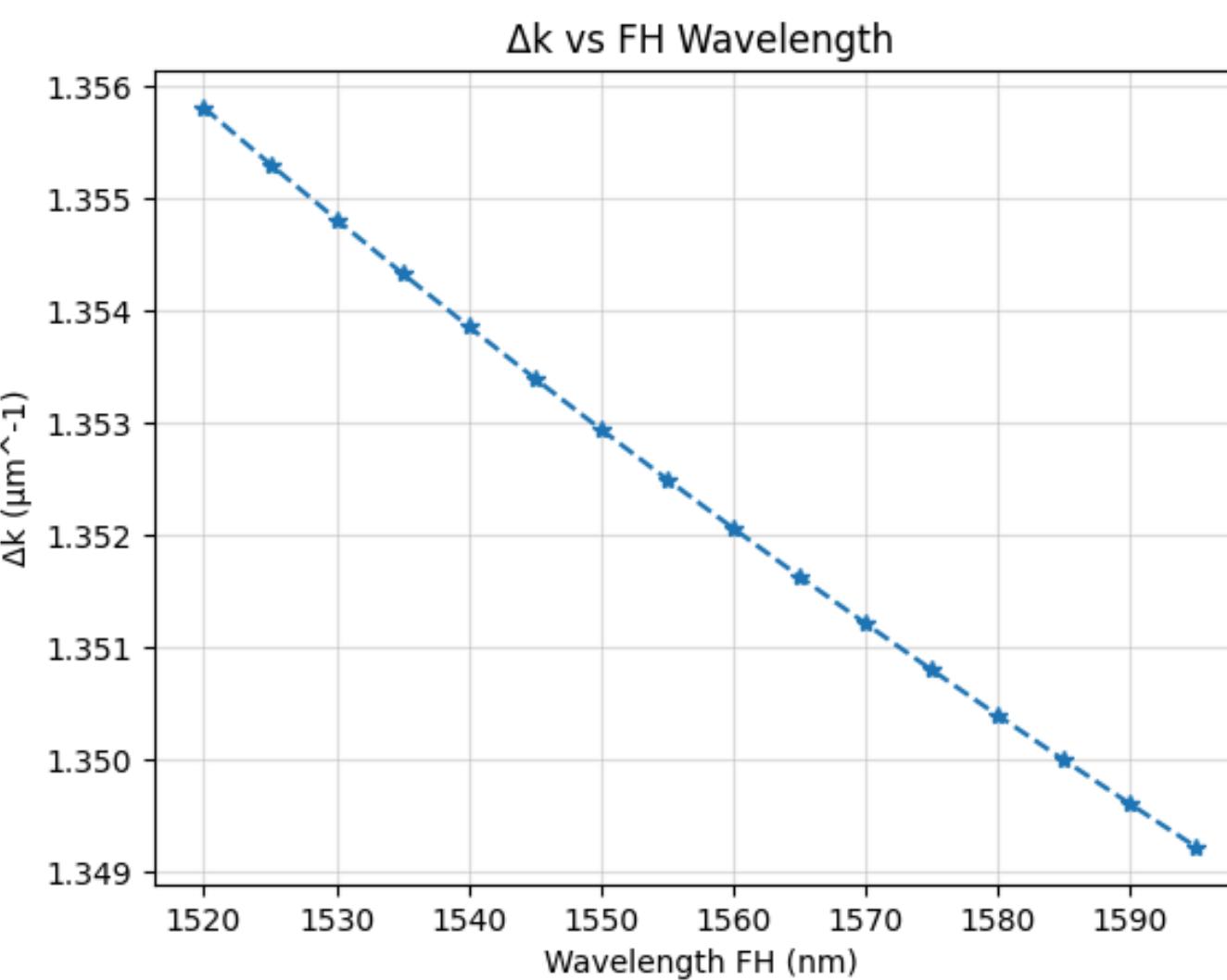


SH mode

# MODE SIMULATIONS

- $\Delta k$  varies smoothly with  $\lambda \rightarrow$  QPM period  $\Lambda$  shifts linearly.
- $\Lambda \approx 4.64\text{-}4.66 \mu\text{m}$  for this  $\text{Si}_3\text{N}_4$  geometry (consistent with [3]).
- Small  $\Delta k$  change  $\rightarrow$  sensitive to dispersion and thermo-optic tuning.

Now, by combining  $\Delta k(\lambda)$  with thermal tuning, is possible to map the double-resonance hotspots.



# EFFECT OF ALL-OPTICAL-POLING (AOP): HOTSPOT EXPANSION AND $\chi^2$ GROWTH

## All-Optical-Poling (AOP):

- Space-charge field grows via photovoltaic effect [1]:
- Feed  $\chi^2$  into SHG coupled-mode equations:
- With AOP  $\chi^{(2)}$  grating  $\rightarrow$  effective mismatch [2]

$$\chi_{\text{eff}}^{(2)}(z, t) = 3\chi^{(3)}E_{\text{sc}}(z, t)$$

$$g \propto \frac{\chi_{\text{eff}}^{(2)}}{\sqrt{A_{\text{eff},\omega}^2 A_{\text{eff},2\omega}}}$$

$$\Delta k_{\text{eff}} = \Delta k - K_G$$

[1] Dianov & Starodubov 1995, Quantum Electron

[2] Nitiss et al. 2019, ACS Photonics

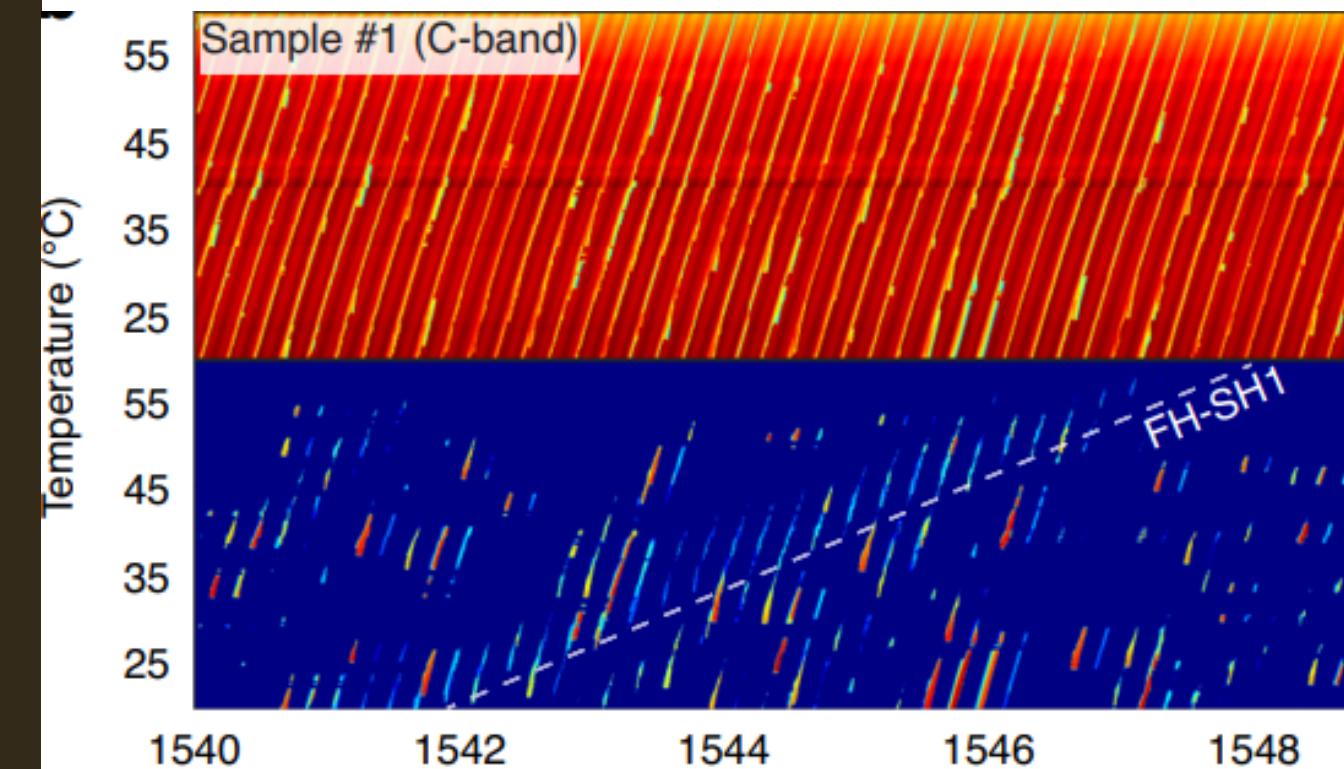
# TEMPERATURE TUNING

- Linear Thermo-Optic tuning:

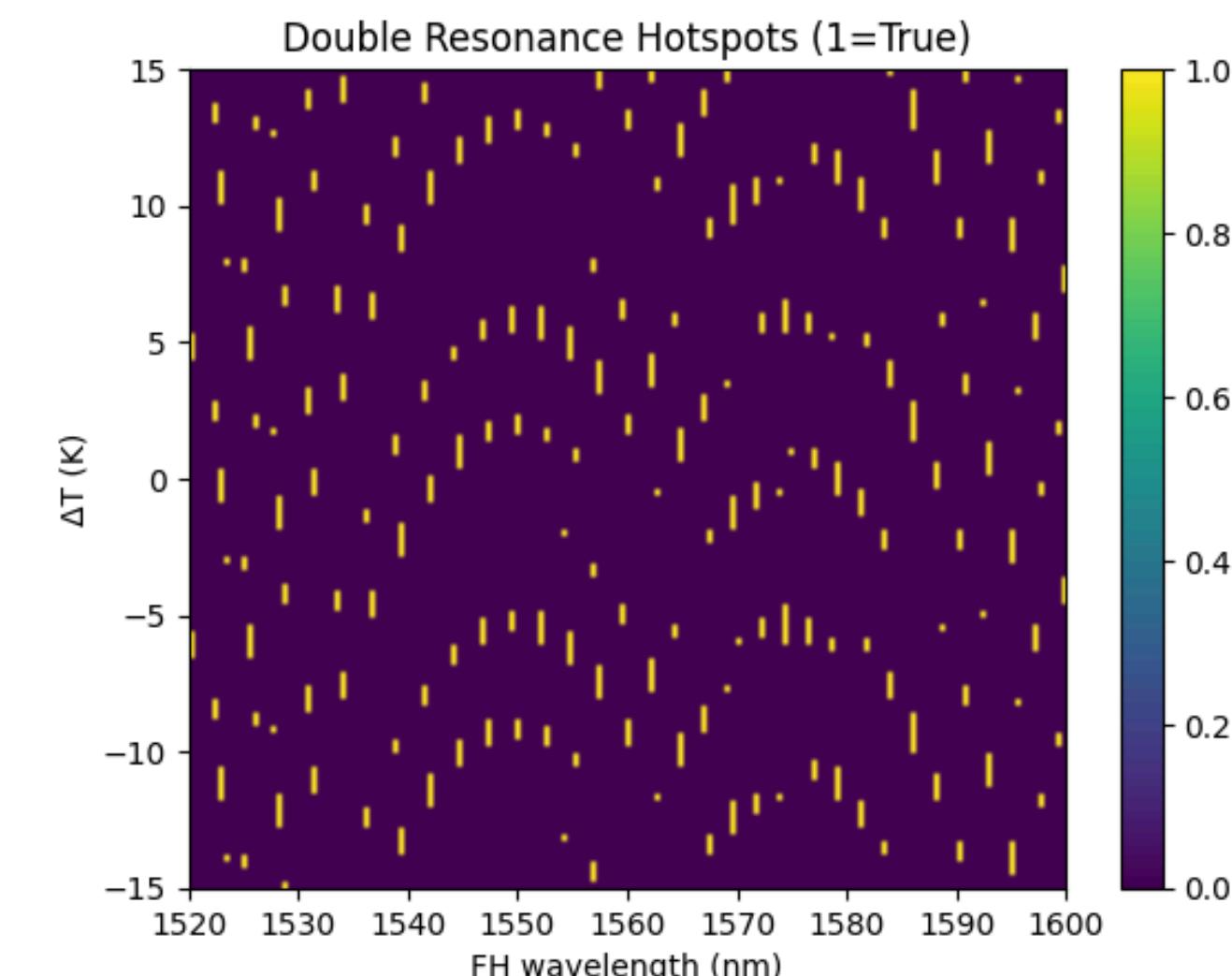
- FH and SH resonances move differently with temperature
- Double resonance requires both to overlap → temperature scanning required:  $(\lambda, \Delta T)$  hotspot map.
- Each vertical streak corresponds to a resonant mode pair  $(w, 2w)$ .

[3] Clementi et al. (2023). Chip-scale SHG via self-injection-locked all-optical poling. Light: Sci. Appl..

$$n_{\text{eff}}(T) = n_{\text{eff}}(T_0) + \frac{dn}{dT}(T - T_0)$$



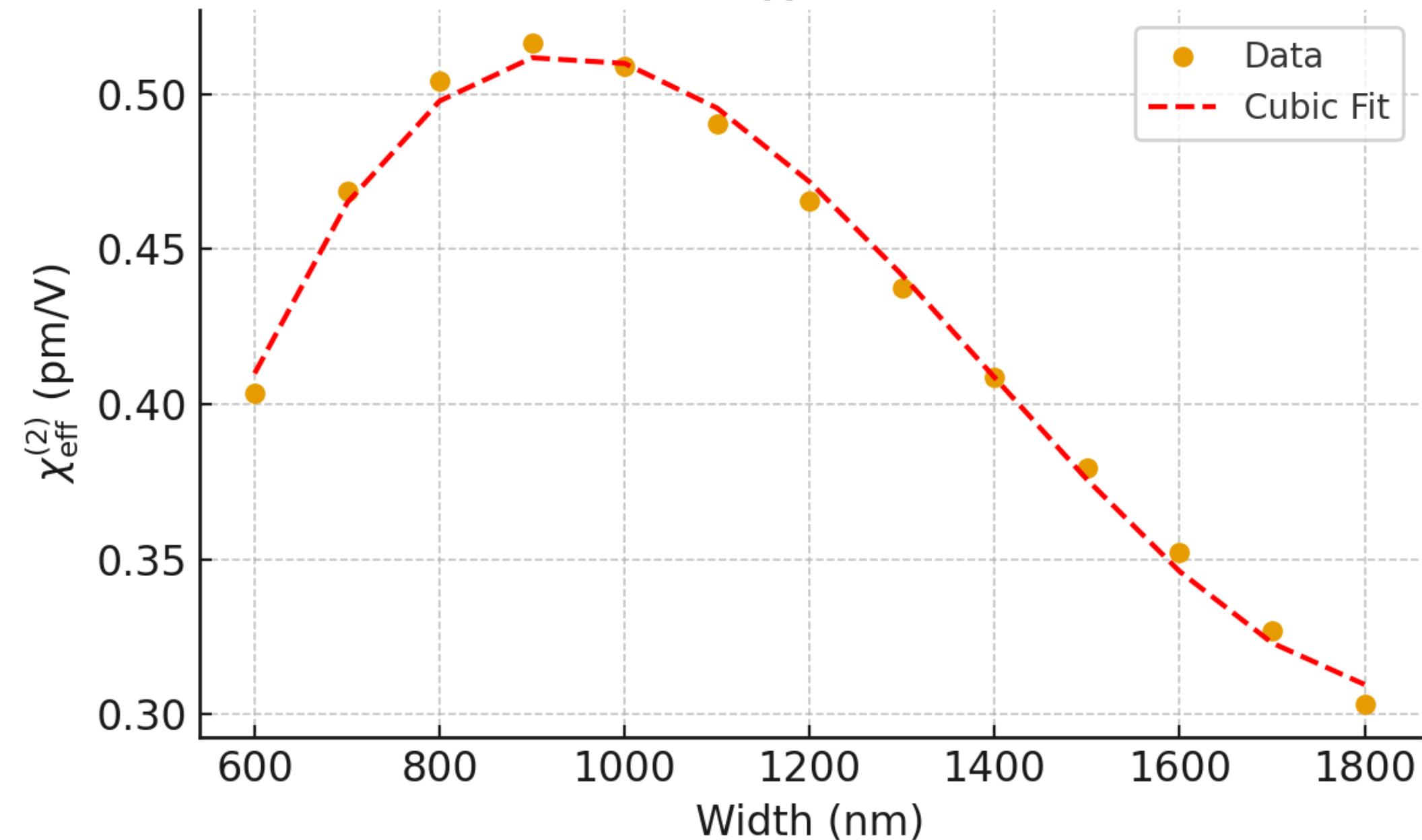
Taken from [3]



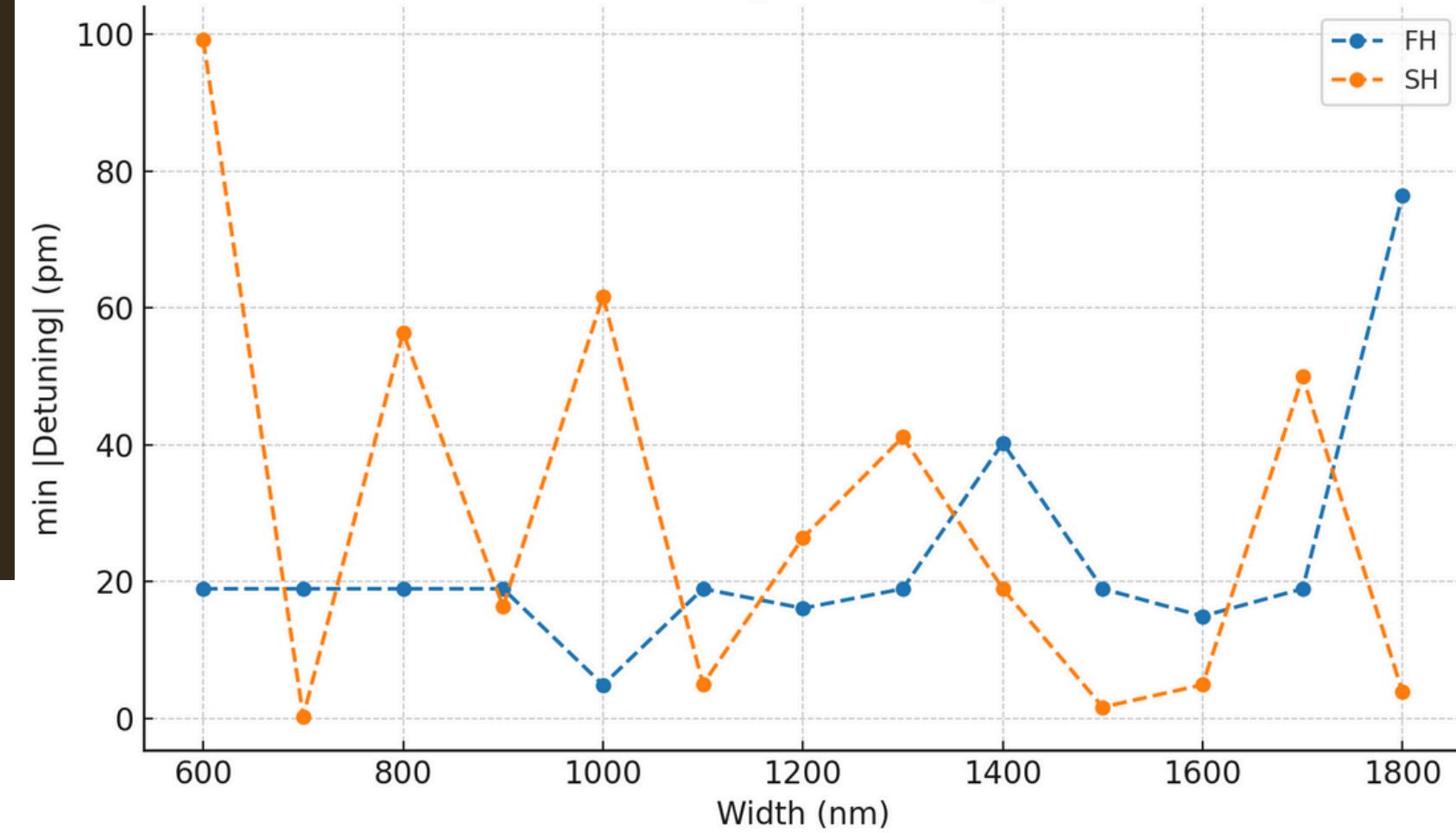
# SHG PERFORMANCE

Minimum detuning enhances double resonance

Effective  $\chi^{(2)}$  vs Width



Minimum Detunings vs Waveguide Width



Maximum spot at 900nm width:

$$\chi^2 = 0.516 \text{ pm/V}$$

$$R^2 = 0.995$$

# SHG PERFORMANCE

- $\chi^2$  grows gradually as the photogalvanic field builds up.
- Saturates after a few seconds: steady  $\chi^2$  available for SHG.

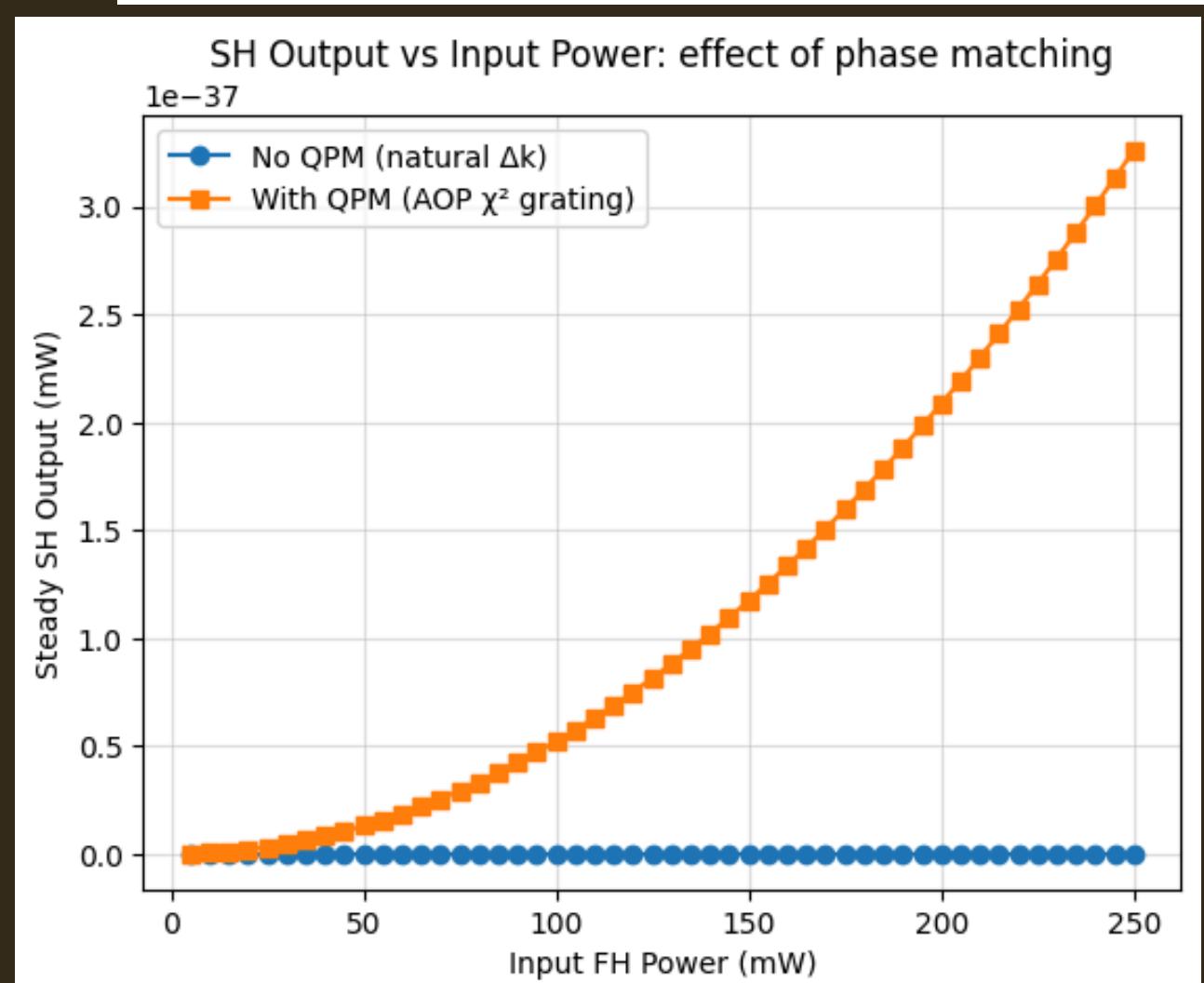
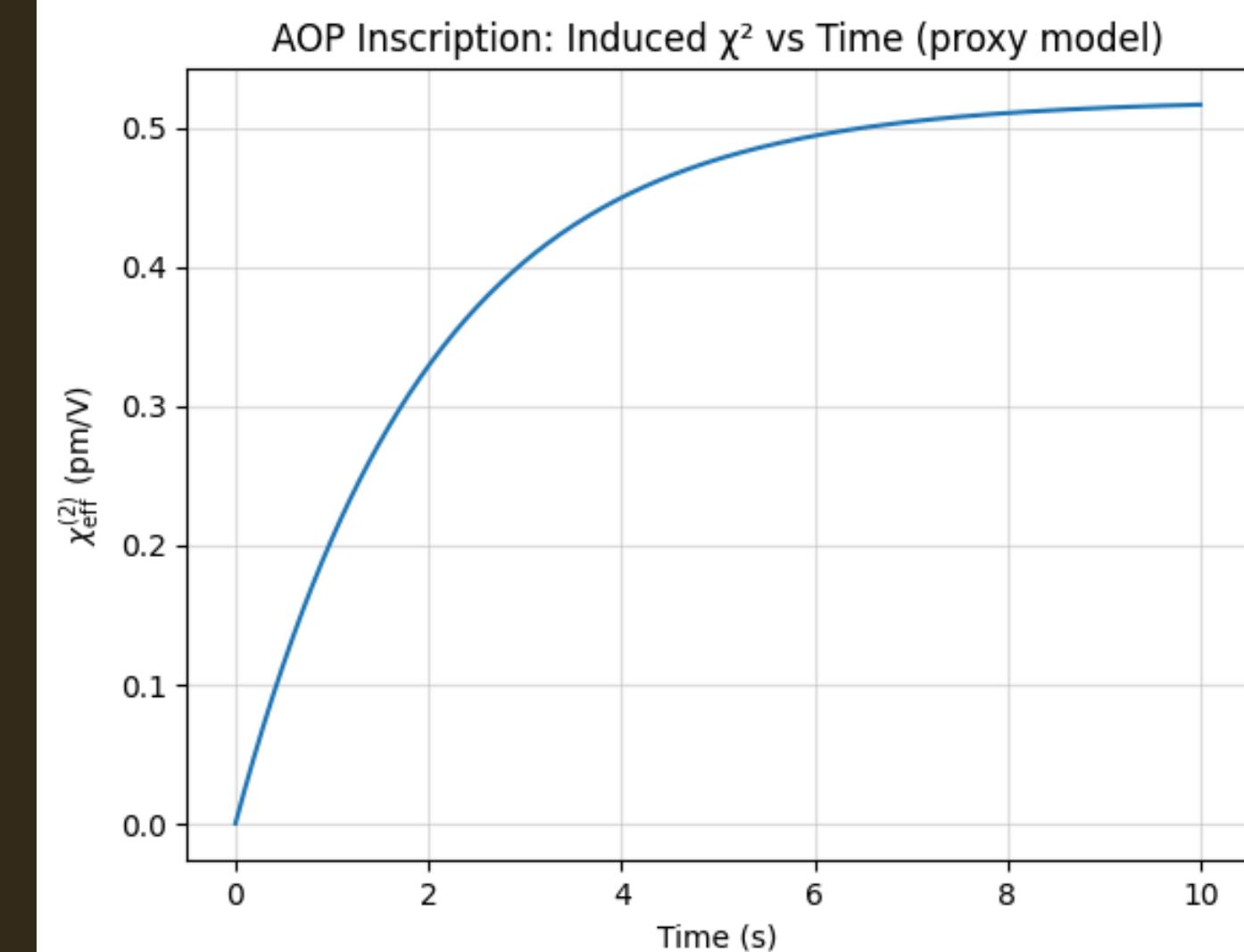


$$\chi^2 = 0.516 \text{ pm/V}$$

- With AOP grating (orange): phase mismatch is compensated.
- SH power grows rapidly and reaches a finite steady level.



$$P = 3.6 \times 10^{-37} \text{ mW}$$



# OUTCOMES AND LIMITATIONS

## OUTCOMES:

- Extracted  $\Delta k(\lambda)$  and  $\Lambda(\lambda)$  from  $\text{Si}_3\text{N}_4$  cross-section
- Exploration of the double resonance hotspots and min detunning
- Demonstrated SHG performance with  $\chi^2$  from simulated AOP, finding a maximum value:

$$\chi^2 = 0.516 \text{ pm/V}$$

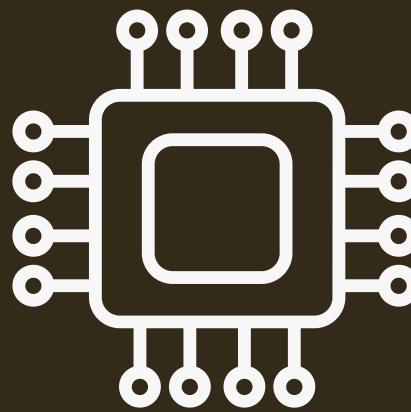
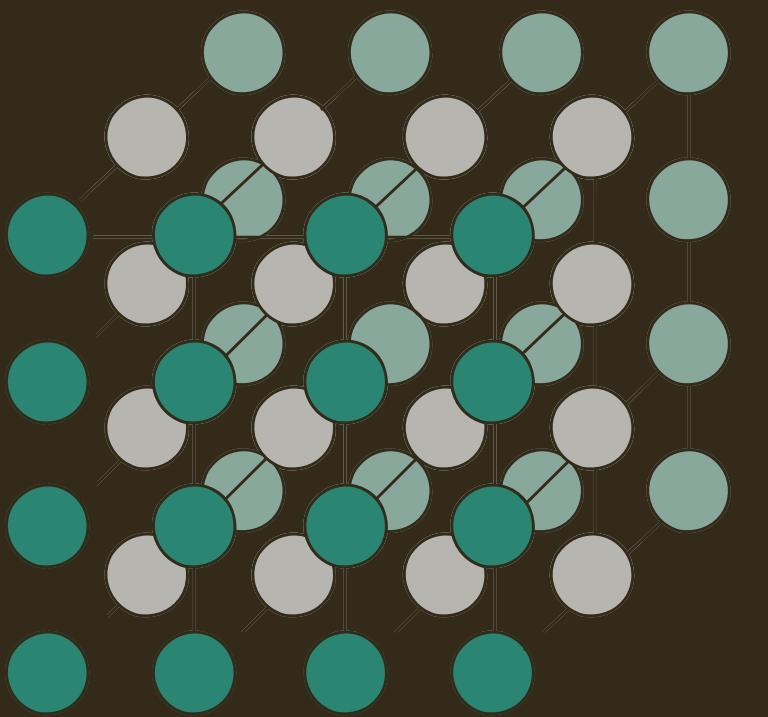
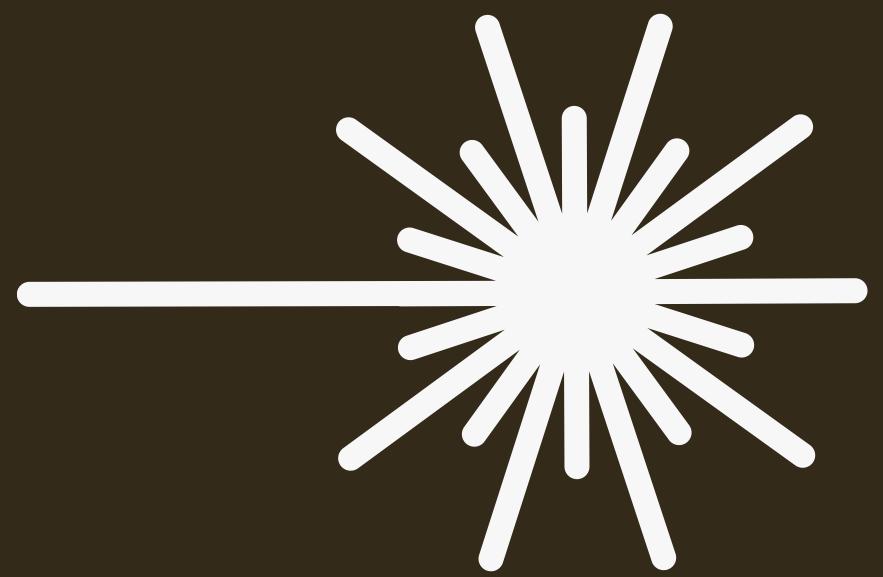
## LIMITATIONS:

- No full 3D ring modes (using straight-waveguide approx)
- Only one geometry fully explored
- Low performance compared with other platforms as Lithium Niobate:

$$\chi^2_{-\text{LN}} = 54 \text{ pm/V}$$

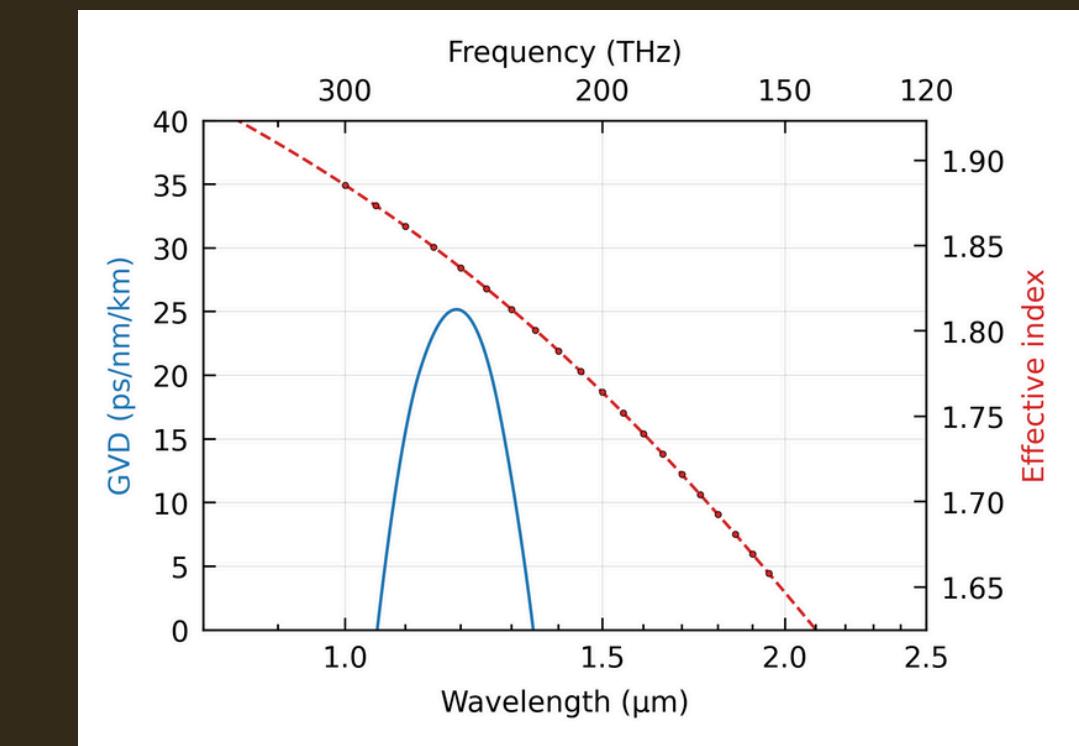
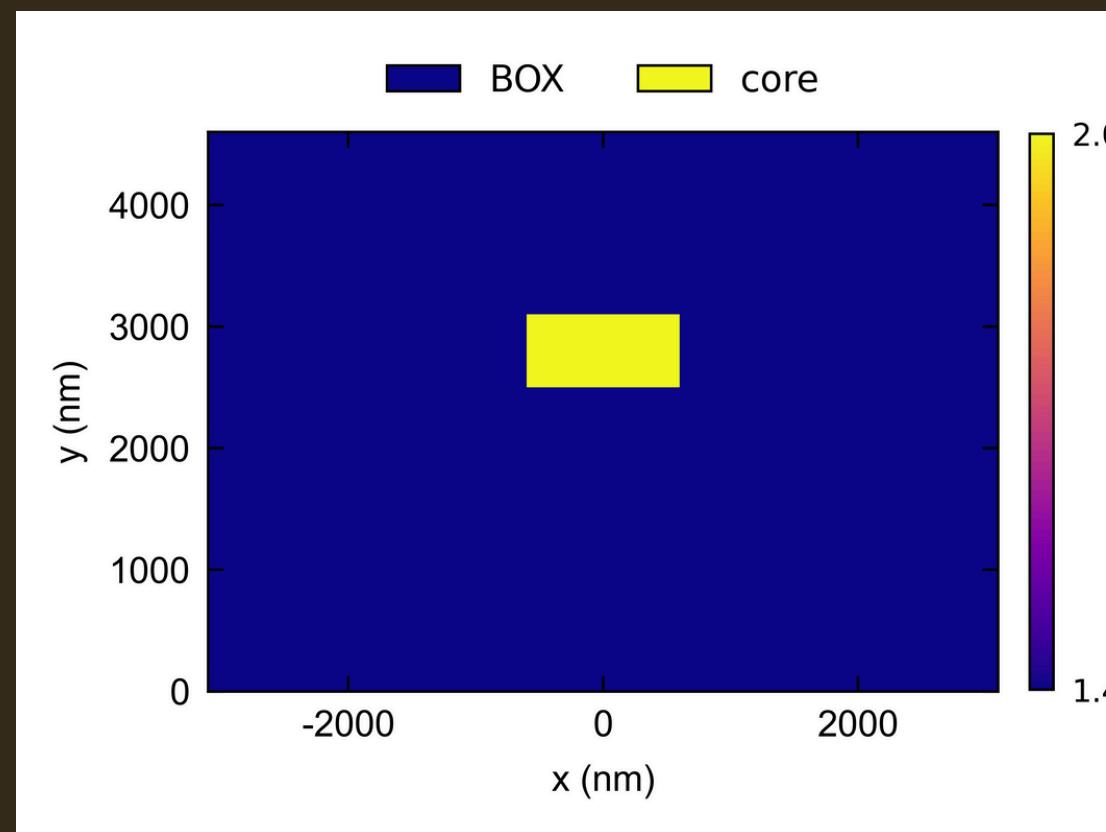
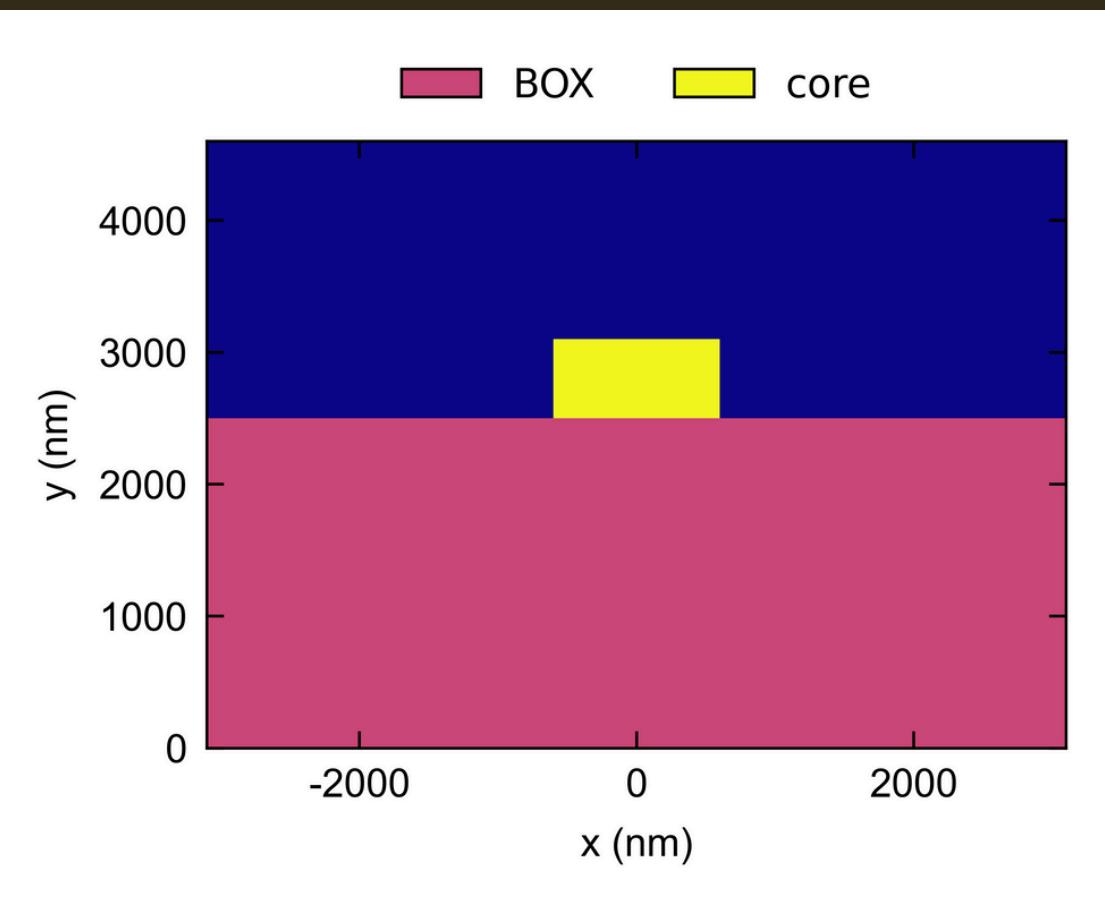
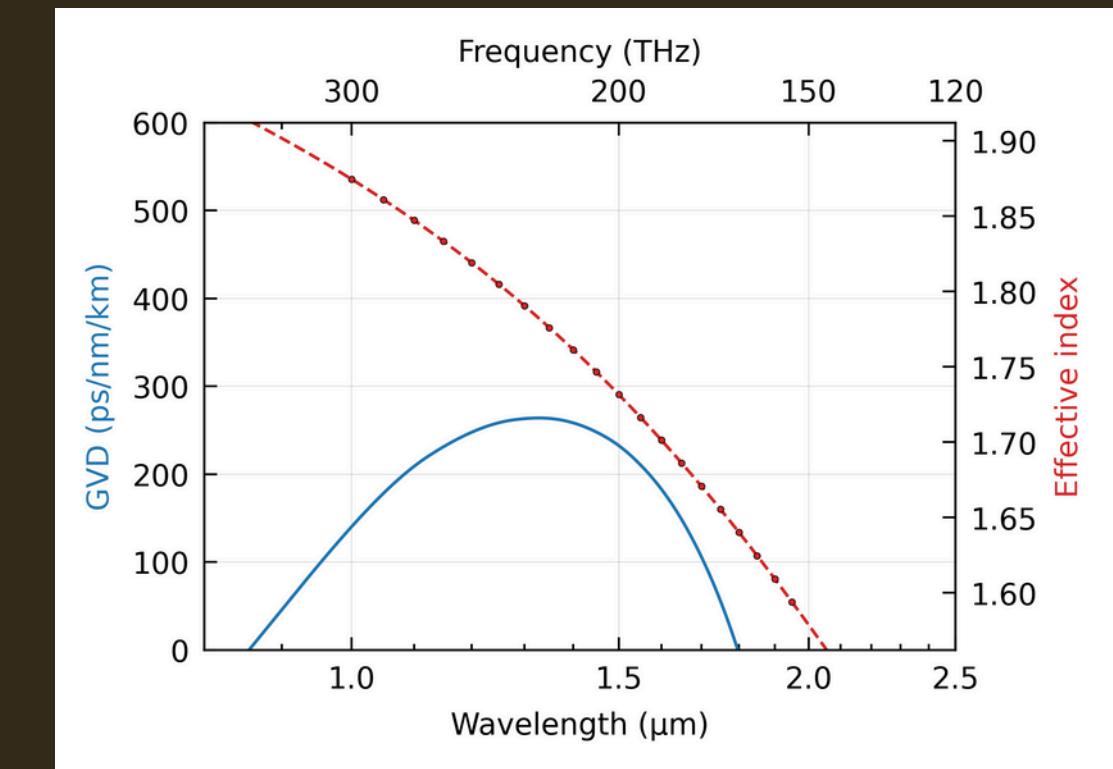
# CONCLUSIONS

- AOP enables  $\chi(2)$  and improves double-resonance in  $\text{Si}_3\text{N}_4$ .
- EMode simulated data ( $\Delta k$ ,  $\Lambda$ ) gives a clear design guidance.
- Hotspot maps show how poling enhances the usable bandwidth.
- Framework ready to explore more geometry sweeps and experimental comparison.



THANKS

# APPENDIX



# APPENDIX

$$n(\lambda) = \sqrt{1 + \frac{3.0249}{1 - (0.135341/\lambda)^2} + \frac{40314}{1 - (1239.84/\lambda)^2}}$$

Wavelength range: 310 nm to 5504 nm

K. Luke, Y. Okawachi, M. R. E. Lamont, A. L. Gaeta, and M. Lipson, "Broadband mid-infrared frequency comb generation in a Si<sub>3</sub>N<sub>4</sub> microresonator," Opt. Lett. 40, 4823 (2015).

# APPENDIX: MODE SIMULATIONS

## 1. Extracted effective refractive indices using EMode:

- $n, \omega(\lambda)$
- $n, 2\omega(\lambda/2)$

## 2. Compute propagation constants

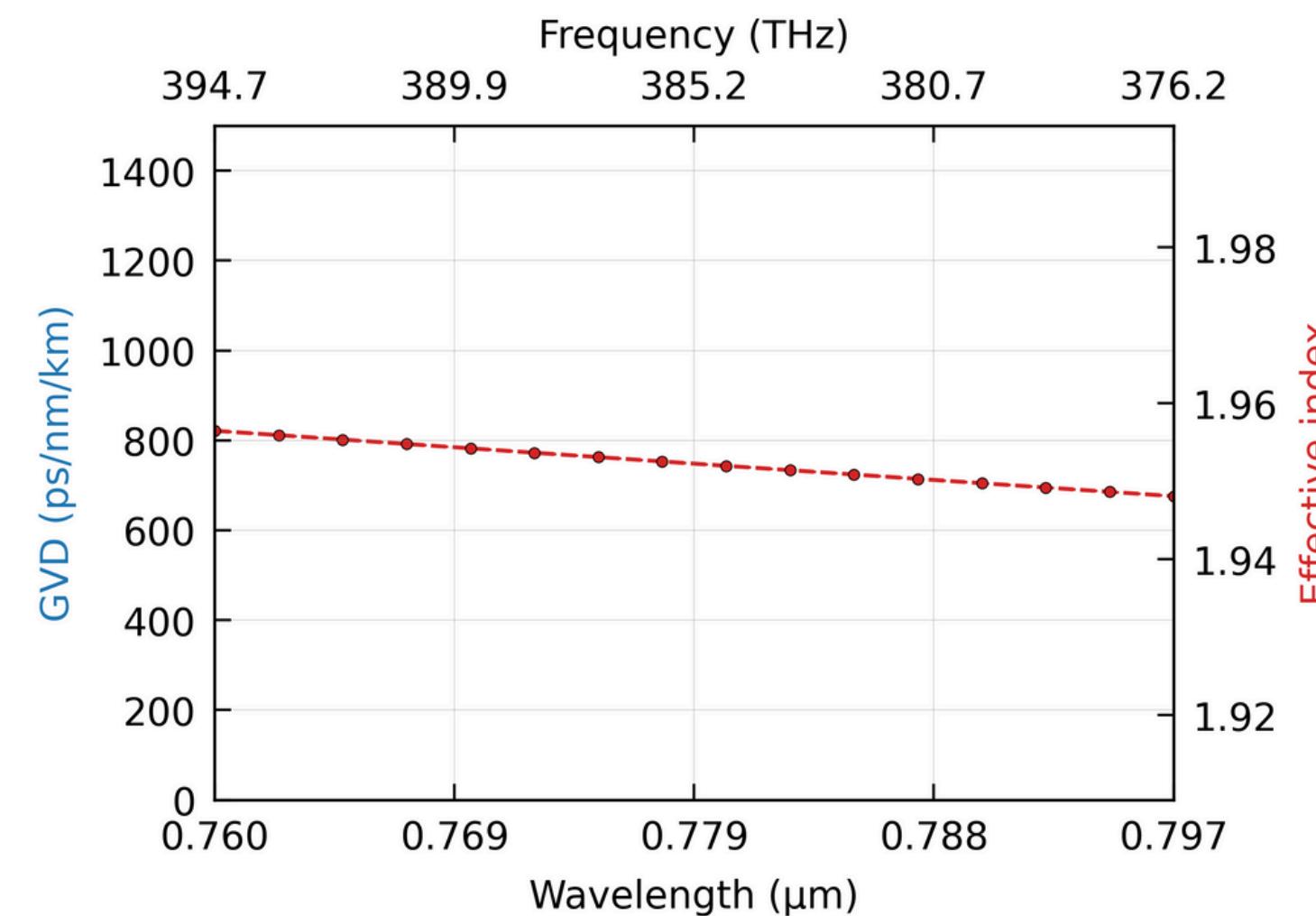
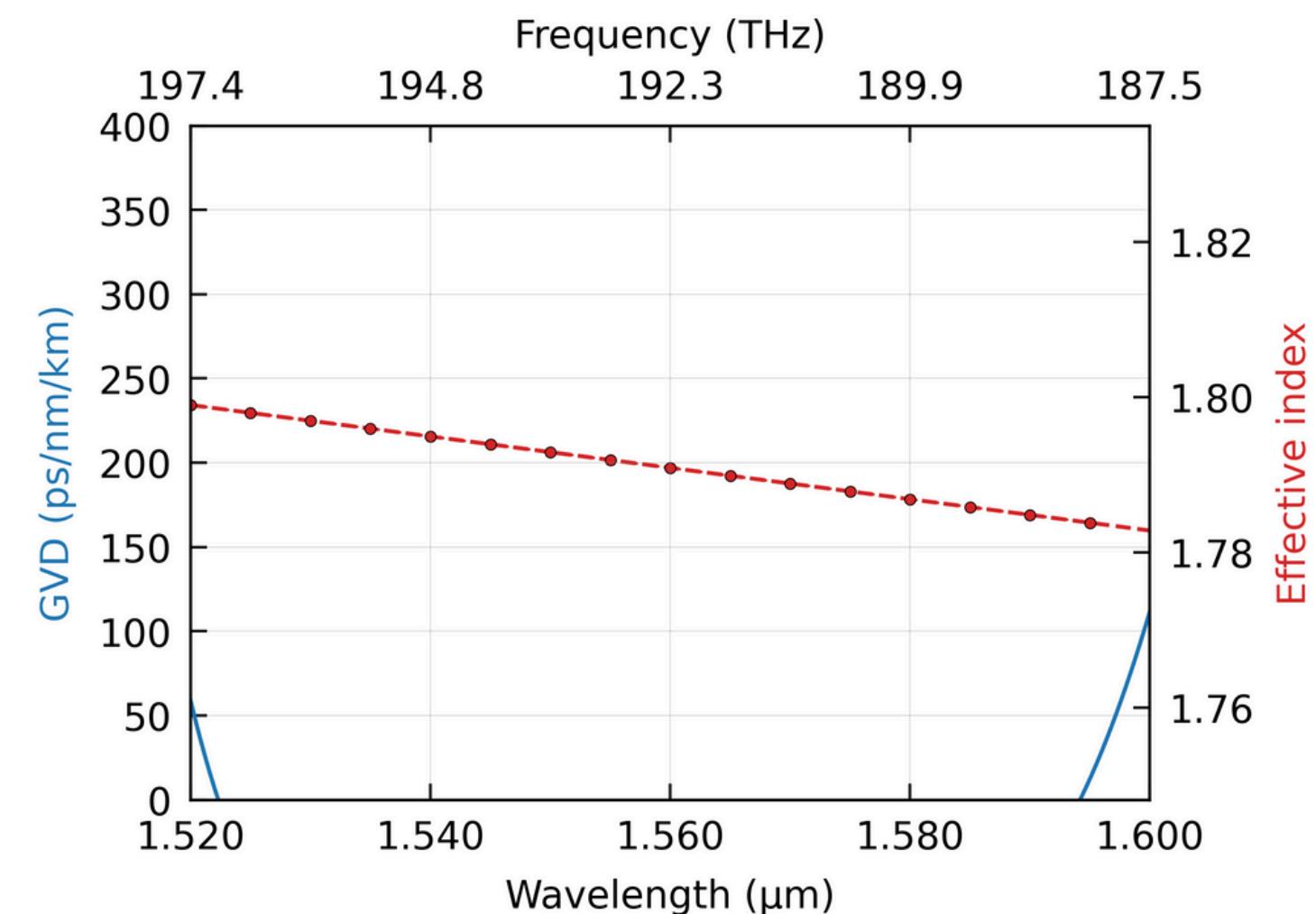
- $\beta = 2\pi n / \lambda$

## 3. Compute phase mismatch

- $\Delta k = \beta(2\omega) - 2\beta(\omega)$

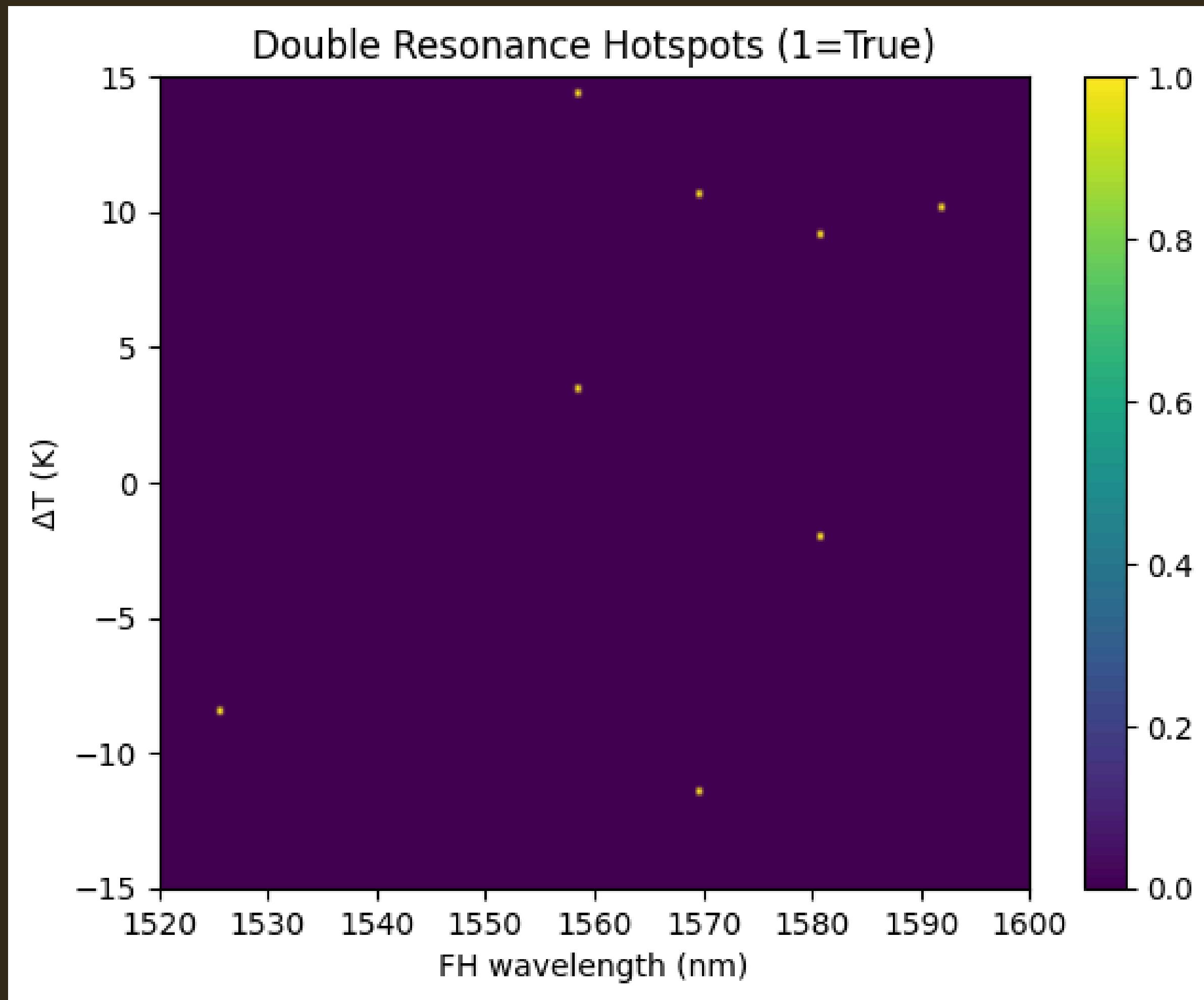
## 4. Compute QPM period

- $\Lambda = 2\pi / |\Delta k|$



# APPENDIX

Almost no  
double-resonant  
hot-spots with a  
1pm detunning



# APPENDIX

## Cubic fit for the effective $\chi^2$

$$\chi_{\text{eff}}^{(2)}(x) = \left(5.30 \times 10^{-10} \frac{\text{pm}}{\text{V} \cdot \text{nm}^3}\right) x^3 - \left(2.22 \times 10^{-6} \frac{\text{pm}}{\text{V} \cdot \text{nm}^2}\right) x^2 + \left(2.76 \times 10^{-3} \frac{\text{pm}}{\text{V} \cdot \text{nm}}\right) x - 0.562 \frac{\text{pm}}{\text{V}}$$

With  $x$  the waveguide width in nm, and a Pearson coefficient  $R^2 = 0.995$ .

# APPENDIX: Theoretical Model

For a microring of circumference  $L = 2\pi R$ , the resonance condition for a given mode is

$$m\lambda = n_{\text{eff}}(\lambda)L$$

Each resonance is characterized by a quality factor  $Q$  that can be decomposed into intrinsic ( $Q_{\text{int}}$ ) and coupling ( $Q_{\text{cpl}}$ ) contributions,

$$\frac{1}{Q_{\text{loaded}}} = \frac{1}{Q_{\text{int}}} + \frac{1}{Q_{\text{cpl}}}. \quad (12)$$

The (power) decay rate at angular frequency  $\omega$  is

$$\kappa = \frac{\omega}{Q_{\text{loaded}}}, \quad (13)$$

with intrinsic and coupling components  $\kappa_{\text{int}}$  and  $\kappa_{\text{ex}}$  defined analogously. These rates are used in the time-domain coupled-mode equations for the intracavity fields.

We adopt a phenomenological rate equation for the average space-charge field  $E(t)$ :

$$\frac{dE}{dt} = A_{\text{CPG}} I_\omega I_{2\omega} - \frac{E}{\tau_{\text{erase}}},$$

We model the intracavity FH and SH fields by slowly varying complex amplitudes  $a(t)$  and  $b(t)$ , normalized such that  $|a|^2$  and  $|b|^2$  are proportional to the intracavity powers. The coupled-mode equations for a doubly resonant  $\chi^{(2)}$  cavity are

$$\dot{a} = \left( i\Delta_\omega - \frac{\kappa_\omega}{2} \right) a + ig ba^* + \sqrt{\kappa_{\omega,\text{ex}}} s_{\text{in}}, \quad (19a)$$

$$\dot{b} = \left( i\Delta_{2\omega} - \frac{\kappa_{2\omega}}{2} \right) b + ig a^2, \quad (19b)$$